



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
United States Patent and Trademark Office
Address: COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, Virginia 22313-1450
www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 3873

SERIAL NUMBER 09/610,637	FILING DATE 07/05/2000 RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. SEL 191
-----------------------------	---------------------------------------	--------------	------------------------	-----------------------------------

APPLICANTS

Koichiro Tanaka, Kanagawa, JAPAN;

Shunpei Yamazaki, Tokyo, JAPAN;
Ritsuko Kawasaki, Kanagawa, JAPAN;

** CONTINUING DATA *****

** FOREIGN APPLICATIONS *****

JAPAN 11-191054 07/05/1999
JAPAN 11-198249 07/12/1999
JAPAN 11-277975 09/30/1999

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 09/07/2000

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged	JAPAN	26	66	9
Examiner's Signature	Initials			

ADDRESS

Cook Alex McFarron Manzo Cummings & Mehler LTD
200 West Adams St
Suite 2850
Chicago , IL
60606

TITLE

Laser irradiation apparatus laser irradiation method, semiconductor device and method of manufacturing a semiconductor device

FILING FEE RECEIVED 2116	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue)
------------------------------------	---	---